**Metal Oxide Semiconductor Field-Effect Transistor (MOSFET)**

Transistors, source, drain and gate. Substrate.

Field-effect transistors use electric field to control the flow of current. They have three terminals, electrical connectors where external circuits can be connected: source (S), drain (D) and gate (G). MOSFET are most commonly used.

MOS is a type of transistor fabricated by the oxidation of a semiconductor.

**CMOS technology and circuit logic**

Complementary metal–oxide–semiconductor (CMOS) is a fabrication method used to integrate transistors on a piece of semiconductor, usually silicon. ~~MOS is a type of transistor fabricated by the oxidation of a semiconductor.~~

In pMOS transistors, **source** (S) and **drain** (D) are connected to p-wells in an n-type substrate. Inversely, in nMOS transistors, source and drain are connected to n-wells in a p-type substrate.

The gate-source voltage V\_GS controls the conductivity over the transistor. The potential difference gives rise to an electric field between gate and substrate.

In nMOS, a positive voltage (with respect to ??) attracts substrate electrons to gate and pushes holes away. With sufficient magnitude gate-source voltage can cause partial inversion, turning a fraction of the p-doped substrate into n-type. This creates an n-channel (hence nMOS) connecting source and drain and allows electron flow between the two. Increasing V\_GS thickens the channel and opens up for greater electron current, increasing conductivity. Similarly, negative gate-source voltage can be applied to pMOS to create a p-channel. Charge carriers of nMOS and pMOS are electrons and holes, respectively.

A voltage can also be applied such that an electric field occurs between source and drain. In nMOS, (a pos/neg voltage with respect to ??) causes the n-channel to retract away from the drain. The channel becomes asymmetrical, its thickness tapers off as it approaches D (fig. ??). Increasing drain-source voltage (V\_DS) can completely disconnect the channel from drain. Though S and D are no longer directly connected, current can still flow. Between the “pinched off” channel tip and drain there is a depleted area where charge can drift. While a uniform n-channel permits current in both directions, the disconnected asymmetrical channel is unidirectional. This mode of operation is called *saturation mode*.

In saturation mode, further increase of V\_DS does not cause current to increase. Electrons are sped up by V\_DS to a point where they reach *carrier velocity saturation* (i.e. maximum velocity) and the current is said to be saturated and constant. [R. Jacob Baker] At this point, raising gate-source voltage can be used to amplify the current.

In a circuit, a saturated MOS transistor works like a switch, current either flows (switch ON) or doesn’t (switch OFF). If input voltage applied to G is high, an n-channel forms in nMOS and current passes though, the switch is “ON”. In pMOS, a high input voltage does not create a p-channel and no current passes the transistor, the switch is “OFF”. Reversely, a low voltage turns nMOS “OFF” while pMOS “ON”.

A close up of a map

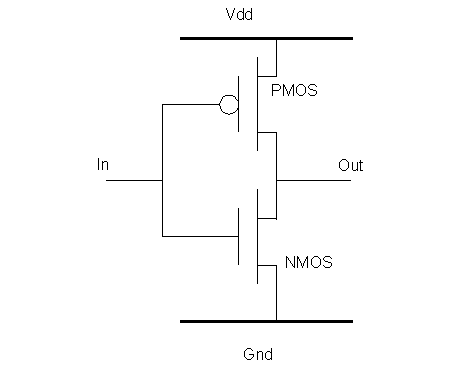
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Operation? Effects of this??

In saturation mode the transistor works as a switch. The current is either ON or OFF. [[\*](https://onlinelibrary.wiley.com/doi/pdf/10.1002/9780470891179), double check source]

By controlling the conductivity, electronical signals can be amplified or switch on/off. (“wiki”) The combination of the complementary **pMOS** and **nMOS** semiconductors in a circuit, create a **CMOS** transistor (pMOS + nMOS = CMOS) as shown in Fig. ??.

A close up of a clock

Description automatically generated

A screen shot of a clock

Description automatically generated

**PIXEL SENSORS**

A pixel sensor is an **imaging sensor** earlier restricted to **light applications**. In later years pixel sensors have been developed to also detect **energetic particles**.

The smallest sensing unit of a pixel sensor is a **pixel**. A matrix of pixels forms a larger sensing area and together with the proper stimulus (light or ionizing particles) they can generate an image. The image **granularity** (spatial resolution) is determined by the pixel size; a large pixel gives low granularity, few pixels fit in a matrix, and a small pixel gives high granularity, many pixels fit in a matrix.

The sensitive mechanism in a pixel is a configuration of semiconductors (photodiodes) which generate a pulse signal as a consequence of ionizing radiation traversing its sensing volume.

There are two types of pixel sensors, active and passive. The main difference between an **Active Pixel Sensor** (APS) and a **Passive Pixel Sensor** (PPS) is that the former incorporates one or more amplifying transistor (MOSFET transistors) while latter does not. Pixels in PPS are read out without amplification. Transistors in an APS convert generated charge to a voltage, amplify the voltage signal and remove noise. These characteristics make APS superior to PPS which has high noise and slow readout rates in comparison.

**MAPS**

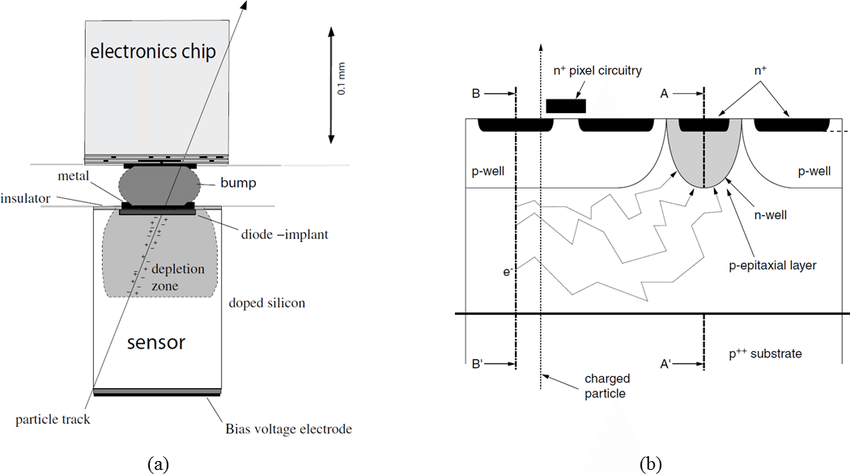
In the early 1990s, APS based on CMOS technology was proposed and at the end of the decade so was their application in particle physics[R.Turchetta ]. CMOS APS implement a monolithic pixel architecture (Fig.??b), with in-pixel circuitry. In contrast, a **hybrid architecture** (Fig.?? a) constitutes of individually manufactured pixel and readout electronics coupled by the means of bump bonding.

MAPS architecture allows for integrated circuitry, which avoids complexities brought by bump bonding and waste of pixel area due to extra material. In comparison to hybrids, MAPS also show significantly lower power consumption of , … (4mW/cm” ish) SOURCE??

while hybrids :few hundred mW/cm2[L.Maczewski].

Small pixels, more functionality

?? Other great interests of MAPS are its low power consumption and low cost …



Sources

[L.Maczewski] MAPS (used by Viljar): https://arxiv.org/pdf/1005.3710.pdf

Moved to ALPIDE:

The sensor is realized on a silicon substrate on which a highly resistive epitaxial layer (sensor active volume) is grown. Into the epitaxial layer p-wells are placed. A potential barrier forms where the heavily p-doped (P++) substrate and (P+) p-wells meet the lightly p-doped (P-) epitaxial layer. Electrons (e) are **vertically confined** by the potential barriers and **diffuse laterally** across pixels.

An important feature is the implementation of a **deep p-well** which shields n-wells of pMOS transistor from the active layer. This prohibits diodes and n-wells from competing in charge collection.

N-well diodes are the sensing elements and are surrounded by the depletion volume. Moderate **reverse bias** can be applied to the substrate in order to increase depletion volume and improve charge collection.

Most part of the epitaxial layer is free of electric field. Charge is left to thermally diffuse in the active volume until collected by the diode or it recombines with the atomic structure. Because of this MAPS have slow collection times, approximately 100ns. [[\*](https://arxiv.org/pdf/1005.3710.pdf)]